



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Tepman, et al.

Serial No.: 09/451,628

Filed: November 30, 1999

For: Integrated Modular Processing
Platform

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Group Art Unit: 1763

Examiner: L. ALEJANDRO

#18A
4/3/01
mw

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING	
37 CFR 1.8	
I hereby certify that this correspondence is being deposited on	
March 27, 2001 with the United States Postal Service as First	
Class Mail in an envelope addressed to: Assistant	
Commissioner for Patents, Washington, D.C. 20231	
March 27, 2001	<i>B. Todd Peterson</i>
Date	Signature

Dear Sir:

RESPONSE TO OFFICE ACTION DATED SEPTEMBER 27, 2000

In response to the Office Action dated September 27, 2000, having a response period extended three months to expire on March 27, 2001, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. Applicants confirm election of Group I without prejudice for prosecution on the merits. The Commissioner is authorized to charge Deposit Account No. 20-0782/AMAT/4285/BTP, along with any other fees necessary to make this response timely.

IN THE SPECIFICATION:

Please replace the paragraph at page 15, lines 9-28, with the following paragraphs:

A' A gas supply system 460 is in communication with the internal volume 454 of the single wafer load lock 314, 316. Gas supply system 460 includes isolation valves 461, 462, 463, meter valve 464 and a diffuser 466. Conduits 467 and 468 couple the various